

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2818**

Docket Number
70404.90/ma

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshihide TSUBATA et al. Application No.: 10/595,640 Confirmation No.: 3891 Filing or 371(c) Date: May 2, 2006 Title: TRANSISTOR AND CVD APPARATUS USED TO DEPOSIT GATE INSULATING FILM THEREOF	Art Unit: 2818 Examiner: E. Taylor
--	---

REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 5, 2008, please reconsider the above-identified application In view of the following remarks.

Listing of the Claims begins on page **2**. No amendments have been made to the Claims.

Remarks/Arguments begin on page **4** of this paper.